



11-27-06

RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 2818  
PATENT  
Attorney Docket No. 04329.3238

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
Gaku MINAMIHABA et al. ) Group Art Unit: 2818  
Application No. 10/771,060 ) Examiner: Goodwin, David J.  
Filed: February 4, 2004 ) Confirmation No.: 2231  
For: POLISHING PAD AND METHOD OF ) Mail Stop AF  
MANUFACTURING )  
SEMICONDUCTOR DEVICES )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AFTER FINAL**

In reply to the Final Office Action mailed August 25, 2006, the period for response to which extends through November 27, 2006 (November 25<sup>th</sup> being a Saturday), and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks/Arguments** follow the amendment section of this paper.